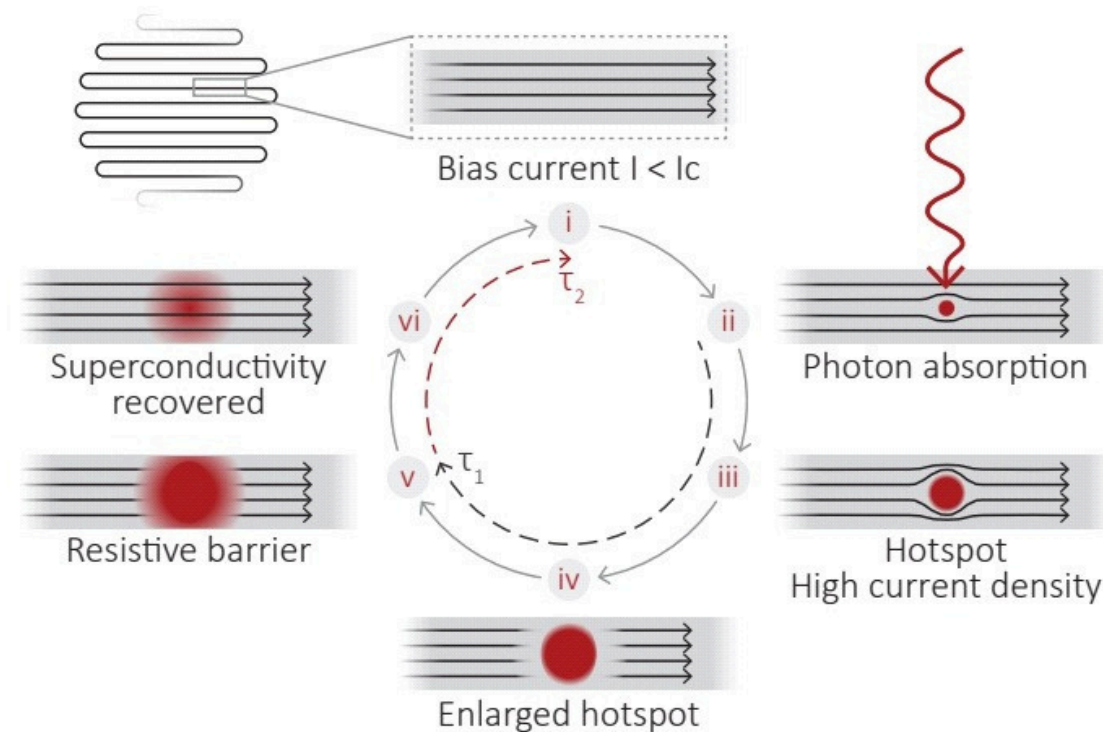


## Introduction

MoSi-based structures are promising for single-photon detection at microwave and millimeter-wave frequencies, where conventional photon counters lose efficiency [1]. Their integration into superconducting circuits enables the development of frequency-tunable photon detectors and low-noise parametric amplifiers.

## Actual problems and research idea

SNSPD consists of a thin (several nanometers) and amorphous superconducting film. The detector made of such a film is patterned in a compact meander geometry to create a square or round pixel with high detection efficiency.



Large gap amplitude for traditional SNSPD (like NbN [2]) materials is efficient in the single-photon detection regime only in a limited frequency range of the InfraRed domain. Such amorphous superconductors as MoSi, were suggested as alternatives to NbN. The deposition technology we use makes it possible to produce ultrathin films with finely tunable sample composition and high  $T_c$ .

Most single photon detectors (SPDs) operate in the near-infrared (NIR) range. Extending detection to longer wavelengths, which are useful for applications such as long-distance quantum communications, remains a challenge.

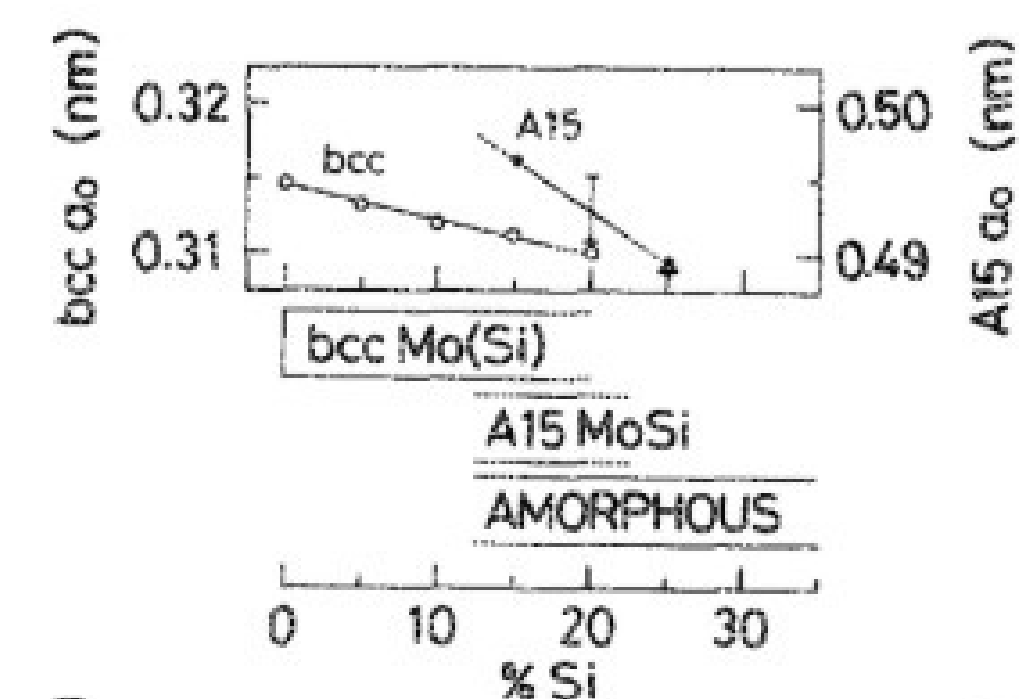
CLASS	FREQUENCY	WAVELENGTH	ENERGY
V	300 EHz	1 pm	1.24 MeV
HX	30 EHz	10 pm	124 keV
SX	3 EHz	100 pm	12.4 keV
EUV	300 PHz	1 nm	1.24 keV
NUV	30 PHz	10 nm	124 eV
VUV	3 PHz	100 nm	12.4 eV
MIR	300 THz	1 $\mu\text{m}$	1.24 eV
MIR	30 THz	10 $\mu\text{m}$	124 meV
FIR	3 THz	100 $\mu\text{m}$	12.4 meV
EHF	300 GHz	1 mm	1.24 meV
SHF	30 GHz	1 cm	124 $\mu\text{eV}$
UHF	3 GHz	1 dm	12.4 $\mu\text{eV}$
VHF	300 MHz	1 m	1.24 $\mu\text{eV}$
HF	30 MHz	10 m	124 neV
MF	3 MHz	100 m	12.4 neV
LF	300 kHz	1 km	1.24 neV
VLF	30 kHz	10 km	124 peV
VF/ULF	3 kHz	100 km	12.4 peV
SLF	300 Hz	1 Mm	1.24 peV
ELF	30 Hz	10 Mm	124 feV
ELF	3 Hz	100 Mm	12.4 feV

## Fabrication method

The magnetron sputtering system is applied. Our technological capabilities enable precise tuning of the normal resistance value of the MoSi superconducting film by controlling its thickness and composition. Advantages of MoSi films

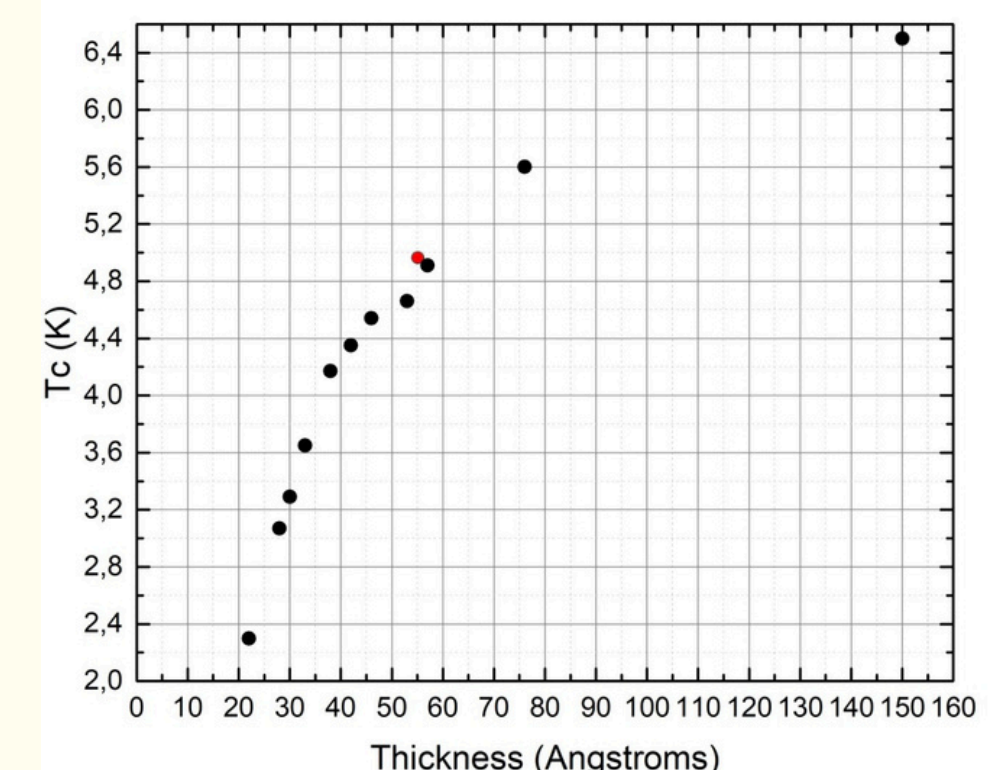
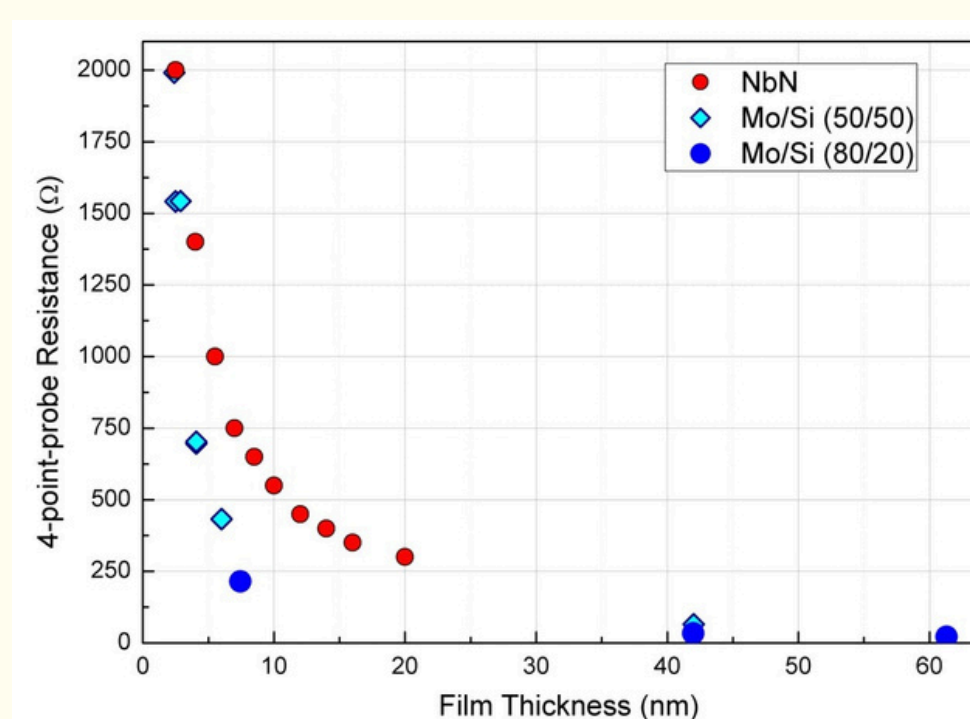
- High critical temperature of superconductivity ( $T_c$ )
- High critical current density ( $J_c$ )
- Technological compatibility with lithography
- Resistance to “aging” and diffusion-isotropy

By research [2], films with more than 80% Mo tend to have bcc structure and lower  $T_c$ .

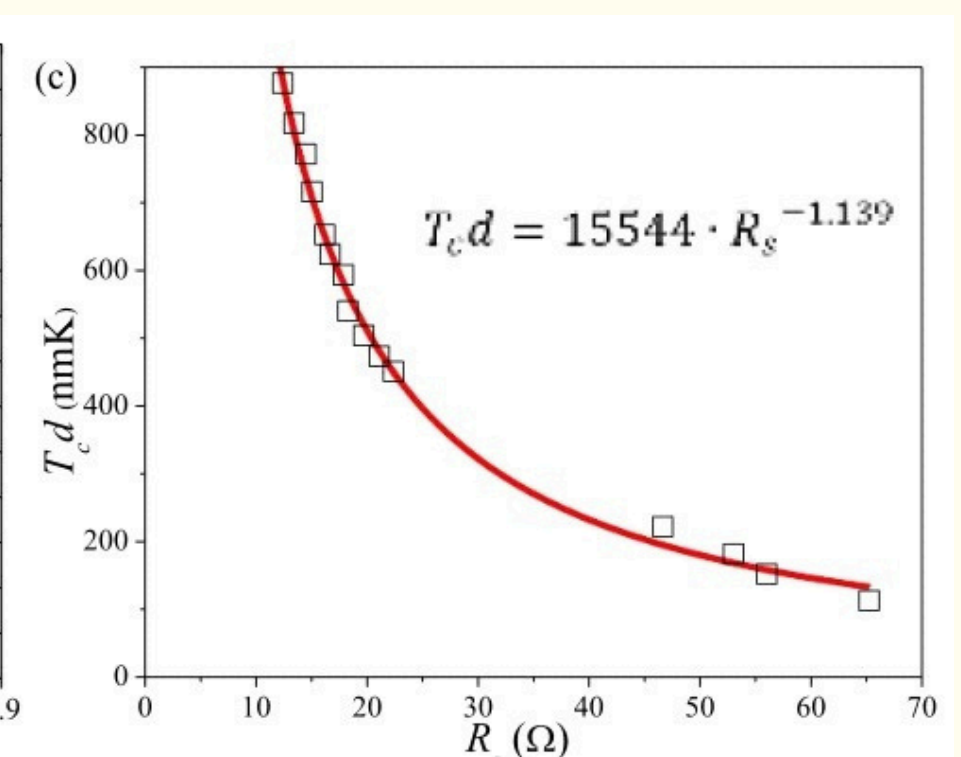
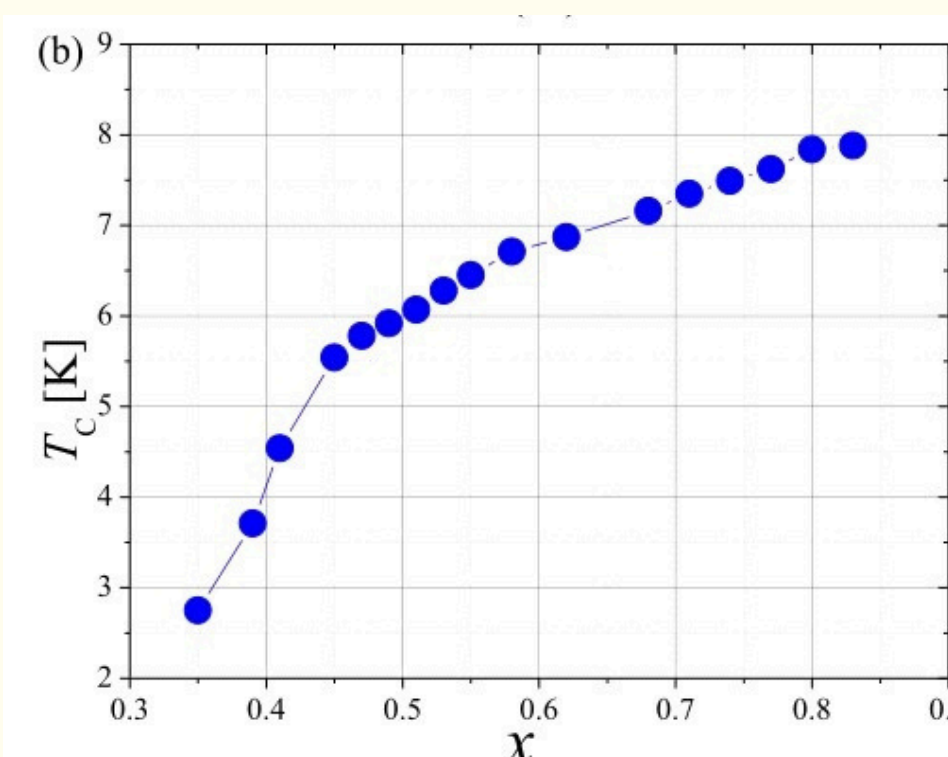


## Results

Thin films with different composition,  $T_c$  and sheet resistance are fabricated.



## Comparison to the published data [3]



## Conclusion & references

Our goal was the preparation of thin amorphous films with high  $T_c$  and high sheet resistance.

- We fabricated and tested amorphous  $\text{Mo}_x\text{Si}_{1-x}$  films for SNSPD;
- The resistance of the samples was measured using the 4-probe method taking into account the geometry of the samples;
- The obtained results show that MoSi films are not inferior in their characteristics to NbN films;
- The vacuum DC magnetron sputtering technique employed enables the fabrication of ultrathin films with precise compositional control.

[1] Yu. P. Korneeva, M. Yu. Mikhailov, Yu. P. Pershin, et al. Supercond. Sci. Technol. 27 (2014).

[2] Kubo S. Superconducting properties of amorphous  $\text{MoX}$  ( $X=\text{Si}, \text{Ge}$ ) alloy films for Abrikosov vortex memory. Journal of Applied Physics. 1988. Vol. 63, no. 6. P. 2033–2045.

[3] X. Zhang, A. Engel, Q. Wang, et al. Phys. Rev. B 94, 174509 (2016)